

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): J. NOGUCHI, et al

Application No.: TBD

Filed: December 23, 2003

For: FABRICATION METHOD OF SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE

Expected Group: 2825

Expected Examiner: B. Keshavan

**CLAIM FOR PRIORITY**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 23, 2003

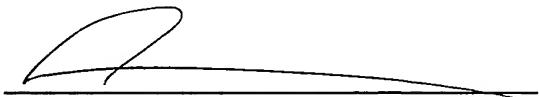
Sir:

Under the provisions of 35 USC §119 and 37 CFR §1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 2000-300853, filed in Japan on September 29, 2000.

A certified copy of the above-identified Japanese Patent Application was filed in prior Application No. 09/965,220, filed September 28, 2001, on November 30, 2001.

Respectfully submitted,

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